

INFORMATION DISCLOSURE STATEMENT

Elers

App. No.

10/719,277

Filed

November 20, 2003

For

MULTILAYER METALLIZATION

Examiner

Unknown

Group Art Unit

2811

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing thirty-two (32) references. Copies of disclosed U.S. patents and/or publications are not included pursuant to PTO waiver of the requirement under 37 C.F.R. § 1.98(a)(2)(i) for applications filed after June 30, 2003. Copies of other references, if listed, are enclosed.

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required in accordance with 37 C.F.R. § 1.97(b)(3). If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

By:

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Adeel S. Akhtar

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Attorney of Record

Customer No. 20,995

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Case Docket No. ASMMC.052AUS

Date: May 10, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant(s)

Elers

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I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

TRANSMITTAL LETTER

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- A PTO Form 1449 listing thirty-two (32) references of which twelve (12) are enclosed. (X)
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

Registration No. 41,394

Attorney of Record

Customer No. 20,995

(415) 954-4114

FORM PTO-1449	U.S. DEPARTMENT OF COMME PATENT AND TRADEMARK OF		ATTY. DOCKET NO. ASMMC.052AUS	APPLICATION NO. 10/719,277
	DISCLOSURE STATEMENT		APPLICANT	
(USE SEVERAL	SHEETS IF NECESSARY)	18. A.	FILING DATE	GROUP

*	-		ilin.	U.S. PATENT DOCUMENTS		<u> </u>	
CAT & TRACTION U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	1	4,450,472	5/22/84	Tuckerman et al.			
	2	4,938,742	7/3/90	Smits			
	3	5,218,515	6/8/93	Bernhardt			
	4	5,241,450	8/31/93	Bernhardt et al.			
	5	5,461,003	10/24/95	Havemann et al.			
	6	5,619,177	4/8/97	Johnson et al.			
	7	5,777,292	7/7/98	Grigorov et al.			
	8	5,901,037	5/4/99	Hamilton et al.			
., ••	9	5,936,295	8/10/99	Havemann et al.			<u> </u>
	10	6,060,383	5/9/00	Nogami et al.			
	11	6,272,169 B1	8/7/01	Boswell, Jr. et al.			
	12	6,482,733	11/19/02	Raaijmakers et al.			
	13	6,534,395	3/18/03	Werkhoven et al.			
	14	6,629,425	10/7/03	Vaiyapuri et al.			<u>.,.</u>
	15	6,686,271	2/3/04	Raaijmakers et al.			
 :	16	6,699,783	3/2/04	Raaijmakers et al.			
	17	6,703,708	3/9/04	Werkhoven et al.			_
,	18	6,727,169	4/27/04	Raaijmakers et al.			12/15/03
	19	US 2003/0032281 A1	2/13/03	Werkhoven et al.			
	20	US 2003/0143839 A1	7/31/03	Raaijmakers et al.			11/22/02

FOREIGN PATENT DOCUMENTS								
EXAMINER		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
INITIAL							YES	NO
<i>ر</i> ہ	21	WO 98/03996	1/29/98	PCT				
し	22	WO 98/03997	1/29/98	PCT				
4	23	WO 98/04109	1/29/98	PCT				
	24	WO 03/053895 A2	7/3/03	РСТ				

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FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMMC.052AUS	APPLICATION NO. 10/719,277
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EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)						
V	Blackburn, J.M. et al., "Deposition of conformal copper and nickel films from supercritical carbon dioxide," Science 294(5540) (2001) pp. 141-145						
ہے	26 Cabanas, A. et al., "Alcohol-Assisted Deposition of Copper Films from Supercritical Carbon Dioxide," J. Chemistry of Materials 15(15) (2003) pp. 2910-2916						
ر ا	27	Dagani, Ron, "Dry Spinning f Carbon Nanotube Yarns"					
Ų	Kondoh, E. et al., "Characteristics of copper deposition in a supercritical CO2 fluid," Microelectronic Engineering 64(1-4) (2002) pp. 495-499						
<i>></i>	Lesiak, B. et al., "Characterization of Polyacetylene and Polyacetylene Doped with Palladium," Polish J. Chem. 74:847-865 (2000)						
	JQ. Lű et al., Advanced Metallization Conference 2000 (ULSI XVI), pp. 515-521.						
٠, ٢		Shirakawa, Hideki et al., "Synthesis of Electrically Conducting Organic Polymers: Halogen Derivatives of Polyacetylene, (CH) _x ," J.C.S., Chem. Comm., 578-580 (1977)					
U	<i>\$</i> 2	Tay, Andrew A.O., "Analytical Study on A MEMS Micro-Cooling System for Cooling of Flip Chips," Conf. on Design, Characterization, and Packaging for MEMS and Microelectronics, Queensland, Australia, Oct. 99, SPIE Vol. 3893, pp. 82-93					
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EXAMINER

DATE CONSIDERED

*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.